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APPLICANTS

Nathan R. Brown, Cedar Park, TX;

** CONTINUING DATA *****

This application is a DIV of 09/912,982 07/25/2001 ~~now~~ us 6863771

lm

** FOREIGN APPLICATIONS *****

oe lm

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 02/12/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after	STATE OR COUNTRY TX	SHEETS DRAWING 7	TOTAL CLAIMS 12	INDEPENDENT CLAIMS 2
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Verified and Acknowledged

Howards
Examiner's Signature

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Initials

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TITLE

Methods for determining amounts and locations of differential pressure to be applied to semiconductor substrates during polishing of semiconductor device structures carried thereby and for subsequently polishing similar semiconductor device structures

FILING FEE RECEIVED 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue)
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